

To U.S. Patent and Trademark Office

References for Information Disclosure
Statement

Serial Number: 10/014,290

Filing Date: December 10, 2001

Inventors: Kyoung Il MIN et al.

Examiner: To Be Assigned

Group Art Unit: 2871

Volume 2 of 2

To U.S. Patent and Trademark Office

References for Information Disclosure
Statement

Serial Number: 10/014,290

Filing Date: December 10, 2001

Inventors: Kyoung Il MIN et al.

Examiner: To Be Assigned

Group Art Unit: 2871

Volume 1 of 2

COPY

PTO/SB/08 (2-92)

Sheet 1 of 3

Form PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets, if necessary)

Docket Number 404302000800

Application Number 10/014,290

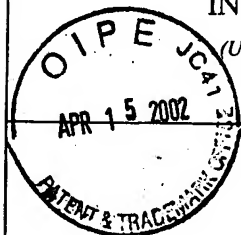
Applicant

Kyoung II MIN et al.

Filing Date December 10, 2001

Group Art Unit 2871

Mailing Date April 10, 2002



RECEIVED
APR 16 2002
TECHNOLOGY CENTER 2800

U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate
	1.	09/08/1970	3,527,535	Monroe			
	2.	11/06/1973	3,771,124	McMahon			
	3.	02/04/1975	3,864,042	Leventhal			
	4.	08/17/1976	3,975,711	McMahon			
	5.	10/17/1978	4,120,585	DePalma et al.			
	6.	01/16/1979	4,135,147	Riganati et al.			
	7.	07/01/1980	4,210,899	Swonger et al.			
	8.	07/20/1982	4,340,300	Ruell			
	9.	11/08/1983	4,414,684	Blonder			
	10.	05/26/1987	4,668,995	Chen et al.			
	11.	07/21/1987	4,681,435	Kubota et al.			
	12.	05/23/1989	4,832,485	Bowles			
	13.	10/03/1989	4,872,203	Asai et al.			
	14.	01/08/1991	4,983,415	Arndt et al.			
	15.	09/24/1991	5,051,576	Schiller			
	16.	03/17/1992	5,096,290	Ohta			
	17.	04/28/1992	5,109,427	Yang			
	18.	01/05/1993	5,177,435	Kiyokawa et al.			
	19.	01/05/1993	5,177,802	Fujimoto et al.			
	20.	02/23/1993	5,189,482	Yang			
	21.	05/11/1993	5,210,588	Lee			
	22.	06/22/1993	5,222,153	Beiswenger			
	23.	08/03/1993	5,233,404	Lougheed et al.			
	24.	05/16/1995	5,416,573	Sartor, Jr.			
	25.	11/14/1995	5,467,403	Fishbine et al.			
	26.	08/20/1996	5,548,394	Giles et al.			

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

PTO/SB/08 (2-92)

pa-675987

Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Form PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket Number 404302000800

Application Number 10/014,290

Applicant

Kyoung II MIN et al.

Filing Date December 10, 2001

Group Art Unit 2871

Mailing Date April 10, 2002

APR 15 2002

PATENT & TRADEMARK OFFICE

RECEIVED
APR 16 2002
TECHNOLOGY CENTER 2800

27.	04/15/1997	5,621,516	Shinzaki et al.			
28.	04/22/1997	5,623,553	Sekiya			
29.	06/03/1997	5,635,723	Fujieda et al.			
30.	10/21/1997	5,680,205	Borza			
31.	03/24/1998	5,732,148	Keagy et al.			
32.	04/07/1998	5,737,071	Arndt			
33.	04/14/1998	5,740,276	Tomko et al.			
34.	08/18/1998	5,796,858	Zhou et al.			
35.	09/22/1998	5,812,252	Bowker et al.			
36.	10/13/1998	5,822,445	Wong			
37.	11/17/1998	5,838,206	Busca et al.			
38.	02/23/1999	5,875,025	Toyoda et al.			
39.	10/05/1999	5,963,657	Bowker et al.			
40.	11/23/1999	5,991,431	Borza et al.			
41.	11/28/2000	6,154,285	Teng et al.			
42.	11/27/2001	6,324,020	Teng et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation and/or Abstract	
							YES	NO
	43.	07/03/1986	JP 61-145686 A	Japan			Abstract	
	44.	10/02/1986	JP 61-221883 A	Japan			Abstract	
	45.	04/04/1987	JP 62-74177 A	Japan			Abstract	
	46.	03/22/1989	0 308 162 A2, 3	Europe				
	47.	05/23/1990	JP 2-133892 A	Japan			Abstract	
	48.	07/24/1990	JP 2-188888 A	Japan			Abstract	
	49.	04/22/1991	JP 3-95693 A	Japan			Abstract	
	50.	09/07/1991	1,286,032	Canada				
	51.	11/05/1991	JP 3-246693 A	Japan			Abstract	
	52.	12/24/1991	JP 3-292578 A	Japan			Abstract	

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

Form PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket Number 404302000800

Application Number 10/014,290

Applicant

Kyoung II MIN et al.

Filing Date December 10, 2001

Group Art Unit 2871

Mailing Date April 10, 2002

RECEIVED
APR 16 2002
TECHNOLOGY CENTER 2800

PE
APR 15 2002
PATENT & TRADEMARK OFFICE

53.	08/27/1993	JP 5-216981	Japan			Abstract
54.	08/13/1994	KR 9407344	Korea			Abstract & Translation
55.	10/05/1994	0 617 919 A2,3	Europe			
56.	05/19/1995	JP 7-131322	Japan			Abstract
57.	09/19/1996	DE 195 09 751 A1	Germany			Abstract
58.	04/17/1997	WO 97/14111 A1	WIPO			
59.	03/19/1998	WO 98/11478 A2	WIPO			
60.	03/19/1998	WO 98/11501 A2,3	WIPO			
61.	03/19/1998	WO 98/11750 A2	WIPO			
62.	06/10/1998	EP 0 847 024 A2,3	Europe			
63.	08/13/1998	WO 98/35118 A1	WIPO			Derwent Abstract
64.	09/30/1998	EP 0 867 828 A2,3	Europe			
65.	09/30/1998	EP 0 867 829 A2,3	Europe			
66.	04/13/1999	JP 11-102432	Japan			Abstract
67.	02/17/2000	WO 00/08591	WIPO			
68.	05/18/2000	WO 00/28469	WIPO			
69.	06/29/2000	WO 00/38099	WIPO			

OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

Examiner Initials	Ref. No.	Title
	70.	Seigo Igaki et al. (1990). "Holographic Fingerprint Sensor," <i>FUJITSU-Sci. Tech. J.</i> 25(4):287-296.

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.